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(11) **EP 0 660 421 A3**

(12) **EUROPEAN PATENT APPLICATION**

(88) Date of publication A3:
05.11.1997 Bulletin 1997/45

(51) Int. Cl.⁶: **H01L 27/146, H04N 1/031**

(43) Date of publication A2:
28.06.1995 Bulletin 1995/26

(21) Application number: **94120730.0**

(22) Date of filing: **27.12.1994**

(84) Designated Contracting States:
DE FR GB IT NL

(30) Priority: 27.12.1993 JP 331690/93
22.08.1994 JP 196640/94
22.08.1994 JP 196641/94
22.08.1994 JP 196642/94
22.08.1994 JP 196643/94
22.08.1994 JP 196644/94
22.08.1994 JP 196645/94
22.08.1994 JP 196648/94
22.08.1994 JP 196670/94
16.12.1994 JP 313392/94

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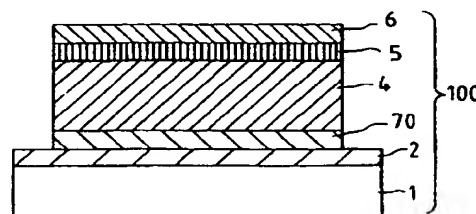
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(54) **Photoelectric converter, its driving method, and system including the photoelectric converter**

(57) A photoelectric converter of a high signal-to-noise ratio, low cost, high productivity and stable characteristics and a system including the above photoelectric converter. The photoelectric converter includes a photoelectric converting portion 100 in which a first electrode layer 2, an insulating layer 70 for inhibiting carriers from transferring, a photoelectric converting semiconductor layer 4 of a non-single-crystal type, an injection blocking layer 5 for inhibiting a first type of carriers from being injected into the semiconductor layer and a second electrode layer 6 are laminated in this order on an insulating substrate 1.

FIG. 4A





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EUROPEAN SEARCH REPORT

Application Number
EP 94 12 0730

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The present search report has been drawn up for all claims			
Place of search THE HAGUE		Date of completion of the search 29 August 1997	Examiner Visscher, E
CATEGORY OF CITED DOCUMENTS X : particularly relevant if taken alone Y : particularly relevant if combined with another document of the same category A : technological background O : non-written disclosure P : intermediate document		T : theory or principle underlying the invention E : earlier patent document, but published on, or after the filing date D : document cited in the application L : document cited for other reasons & : member of the same patent family, corresponding document	

EPO FORM 1503 03/82 (P04C01)



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Application Number
EP 94 12 0730

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<p>CATEGORY OF CITED DOCUMENTS</p> <p>X : particularly relevant if taken alone Y : particularly relevant if combined with another document of the same category A : technological background O : non-written disclosure P : intermediate document</p> <p>T : theory or principle underlying the invention E : earlier patent document, but published on, or after the filing date D : document cited in the application L : document cited for other reasons</p> <p>& : member of the same patent family, corresponding document</p>			

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